## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Mieher, et al. Attorney Docket No.:

KLA1P117X1A/P1151 CIP1

Application No.: 10/785,396

Examiner: Gordon J. Stock Jr.

Filed: February 23, 2004

Group: 2877

Title: APPARATUS AND METHODS FOR

DETECTING OVERLAY ERRORS USING Confirmation No.: 6516

**SCATTEROMETRY** 

## CERTIFICATE OF EFS-WEB\_TRANSMISSION

I hereby certify that this correspondence is being transmitted electronically through EFS-WEB to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on January 30, 2008.

Signed:	/Tara Hayden/
	Tara Havden

## AMENDMENT C

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

It is respectfully submitted that the Examiner enters the following amendments in response to the Office Action dated 30 October 2007, a response to which is due 30 January 2008.

**Amendments to the Claims** are reflected in the listing of claims that begin on page 2 of this paper.

**Remarks/Arguments** begin on page 11 of this paper.

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